

PATENT



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Raquel C. West

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Todd H. Steinberg Examiner: Unassigned
Serial No.: 10/053,369 Group Art Unit: Unassigned
Filed: November 2, 2001
Title: System And Method For Measuring Beam Quality And Dosimetry Using Electronic Portal Imaging

Assistant Commissioner for Patents
Washington, DC 20231

PETITION FOR EXTENSION OF TIME

Sir:

Applicants hereby petition for an extension of time in the above-identified patent application in order to respond to the Notice of Incomplete Reply on a Non-Provisional Application mailed on May 28, 2002. This extension is for one (1) month and will extend the original due date of the Notice to File Corrected Application Papers from May 20, 2002 to June 20, 2002. A response is enclosed herewith.

Please charge Deposit Account No. 19-2179 for the extension fee of \$110.00. The Assistant Commissioner is authorized to charge any fees or credit any overpayments to Deposit Account No. 19-2179. A duplicate copy of this petition is enclosed.

Respectfully submitted,

PLEASE MAIL CORRESPONDENCE TO:
Siemens Corporation
Attn: Elsa Keller, Legal Administrator
Intellectual Property Department
186 Wood Avenue South
Iselin, NJ 08830

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